

Patent

Docket No. 1232-4609US1



27123

PATENT TRADEMARK OFFICE

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kazuaki OHMI et al.

Serial No.: *To be assigned*

Group Art Unit: *To be assigned*

Filed: June 25, 2003

Examiner: *To be assigned*

For: SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF  
MANUFACTURING SEMICONDUCTOR SUBSTRATE

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references listed on the attached Form PTO 1449. Copy(ies) of these references ☒ are attached ☐ were filed in related application U.S. Serial No(s) \_\_\_\_\_, filed \_\_\_\_\_, respectively.

- ☐ This document is being filed within three (3) months of the filing date of the application
- ☐ Please charge the \$180 fee to Deposit Account No. 13-4503, Order No. \_\_\_\_\_.
- ☒ This document is being concurrently filed with the above-identified application
- ☐ This document is being concurrently filed with an Request for Continued Examination (RCE)
- ☐ This document is being filed prior to a first Office Action
- ☐ This document is accompanied by a Search Report/Communication cited in a corresponding PCT or foreign counterpart application.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required for this Information Disclosure Statement, or credit any overpayment to Deposit Account No. 13-4503, Order No. 1232-4609US1. A DUPLICATE COPY OF THIS SHEET IS ATTACHED.

Respectfully submitted,  
MORGAN & FINNEGAN, L.L.P.

Dated: June 25, 2005

By: \_\_\_\_\_

James Hwa  
Registration No. 42,680

**Correspondence Address:**

MORGAN & FINNEGAN, L.L.P.  
345 Park Avenue  
New York, NY 10154-0053  
(202) 857-7887 Telephone  
(202) 857-7929 Facsimile

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE CITATION</b>				Attorney Docket:		Serial No.:	
				1232-4609US1		To Be Assigned	
				Applicants:			
				Kazuaki OHMI, et al.			
Filing Date:				Group Art Unit:			
June 25, 2003				To Be Assigned			
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	1	6,102,529	08/15/00	Okazaki et al.	347	65	
	2	6,077,383	06/20/00	Laporte	156	344	
	3	5,783,022	07/21/98	Cha et al.	156	344	
	4	5,363,556	11/15/94	Banholzer et al.	29	890.142	
	5	4,466,852	08/21/84	Beltz et al.	156	344	
	6	3,969,813	07/20/76	Minetti et al.	29	575	
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Classes	Sub-Class	Translation
	7	JP 11-45840	02/16/99	Japan (w/ English Abstract)			<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
	8	JP 7-302889	11/14/95	Japan (w/ English Abstract)			<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
	9	JP 5-21338	01/29/93	Japan (w/ English Abstract)			<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
	10	EP 0 867 917 A2	09/30/98	European			<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
							<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
							<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
							<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
							<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No
<b>OTHER DOCUMENTS (Including Author, Title, Date, etc.)</b>							
	11	"History of Water Jet Machining Development", <u>Journal of Water Jet Technology</u> , Society of Japan, Vol. 1, 1/1/84					
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							